

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
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		Examiner	Art Unit	Page 1 of 1
		Jennifer Kim	1617	

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*	C	US-6,710,050	03-2004	Weibel et al.	514/266.2
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**NON-PATENT DOCUMENTS**

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